



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) : Examiner: Carol M. Koslow
MAKOTO KUBOTA, et al.)
Application No.: 10/665,429	: Group Art Unit: 1755
Filed: September 22, 2003) :
For: COMPOSITION FOR FORMING PIEZOELECTRIC FILM, MANUFACTURING METHOD OF PIEZOELECTRIC FILM, PIEZOELECTRIC FILM,) :) :
PIEZOELECTRIC ELEMENT AND INK JET RECORDING HEAD) :) January 23, 2006 (Monday)
Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	
<u>AMENDMENT</u>	
Sir:	
In response to the Office Action dated September 21, 2005, the period for	
response to which having been extended to Monday, January 23, 2006 by the	
accompanying Petition for Extension of Time, please amend the above-identified	
application, as follows:	
	I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
	(Date of Deposit)
	Damond E. Vadnais, Reg. No. 52,310 (Name of Attorney for Applicant)
	Signature January 23, 2006 Date of Signature